

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary) PTO Form 1449	Atty Docket No. 112857-319	Application No. 10/092,687
	Applicant Hiroyuki Okuyama et al.	
	Filing Date 03/06/2002	Group 2822

U.S. PATENT DOCUMENTS

Examiner's Initials	Document Number	Publication Date	Inventor	Class	Subclass	Filing Date If Appropriate
MP	5,177,405	01/05/1993	Kusuda et al.	_____	_____	_____
MP	5,981,977	11/09/1999	Furukawa et al.	_____	_____	_____

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
						Yes	No
MP	✓ 56-92577	07/27/1981	Japan	_____	_____	_____	✓
MP	✓ 57-45583	03/15/1982	Japan	_____	_____	_____	✓
MP	✓ 57-52071	03/27/1982	Japan	_____	_____	_____	✓
MP	✓ 57-52072	03/27/1982	Japan	_____	_____	_____	✓
MP	✓ 57-52073	03/27/1982	Japan	_____	_____	_____	✓
MP	✓ 58-50577	03/25/1983	Japan	_____	_____	_____	✓
MP	✓ 61-156780	07/16/1986	Japan	_____	_____	_____	✓
MP	✓ 63-188938	08/04/1988	Japan	_____	_____	_____	✓
MP	✓ 64-149491	06/12/1989	Japan	_____	_____	_____	✓
MP	✓ 72-263668	10/26/1990	Japan	_____	_____	_____	✓
MP	✓ 83-035568	02/15/1991	Japan	_____	_____	_____	✓
MP	✓ 84-45648	02/18/1994	Japan	_____	_____	_____	✓
MP	✓ 86-067044	03/11/1994	Japan	_____	_____	_____	✓
MP	✓ 87-199829	04/08/1995	Japan	_____	_____	_____	✓
MP	✓ 87-283438	10/27/1995	Japan	_____	_____	_____	✓
MP	✓ 88-008217	01/12/1996	Japan	_____	_____	_____	✓
MP	✓ 88-274376	10/18/1996	Japan	_____	_____	_____	✓
MP	✓ 91-129974	05/16/1997	Japan	_____	_____	_____	✓
MP	✓ 99-274455	10/21/1997	Japan	_____	_____	_____	✓
MP	✓ WO 97/44612	11/27/1997	PCT	_____	_____	_____	✓
MP	✓ 10-125929	05/05/1998	Japan	_____	_____	_____	✓
MP	✓ 10-270801	10/09/1998	Japan	_____	_____	_____	✓
MP	✓ 10-312971	11/24/1998	Japan	_____	_____	_____	✓
MP	✓ 11-26883	01/29/1999	Japan	_____	_____	_____	✓

Examiner: *[Signature]*

Date Considered: 9/04

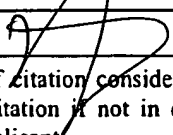
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary) PTO Form 1449	Atty Docket No. 112857-319	Application No. 10/092,687
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FOREIGN PATENT DOCUMENTS

Examiner's Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No
MP	✓	11-075019	03/16/1999	Japan	—	—	—	✓
MP	✓	11-177138	07/02/1999	Japan	—	—	—	✓
MP	✓	11-251253	09/17/1999	Japan	—	—	—	✓
MP	✓	11-312840	11/09/1999	Japan	—	—	—	✓
MP	✓	11-514136	11/30/1999	Japan	—	—	—	✓
MP	✓	11-329745	11/30/1999	Japan	—	—	—	✓
MP	✓	11-346004	12/14/1999	Japan	—	—	—	✓
MP	✓	2000-068593	03/03/2000	Japan	—	—	—	✓
MP	✓	2000-183451	06/30/2000	Japan	—	—	—	✓
MP	✓	2000-223417	08/11/2000	Japan	—	—	—	✓
MP	✓	2000-332343	11/30/2000	Japan	—	—	—	✓
MP	✓	2001-085738	03/30/2001	Japan	—	—	—	✓
MP	✓	2001-184921	07/06/2001	Japan	—	—	—	✓
MP	✓	2001-217503	08/10/2001	Japan	—	—	—	✓
MP	✓	2002-185660	12/12/2002	Japan	—	—	—	✓

Examiner's Initials		OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
MP	✓	Zheleva et al., <i>Pendeo-epitaxy – a new approach for lateral growth of gallium nitride structures</i> , MRS Internet J. Nitride Semicond. Res. 4S1, G3.38 (1999).
MP	✓	Kapolnek et al., <i>Spatial control of InGaN luminescence by MOCVD selective epitaxy</i> , Journal of Crystal Growth, 189/190 (1998) pp. 83-86.

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